

# GaAs MMIC Wide Voltage Amplifier Chip, 13.5-14.5GHz

#### Performance characteristics

Frequency range: 13.5-14.5 GHz Wide voltage operation:  $+5V \rightarrow +6V$ Small signal gain : 30 dB@+5V , 2 9 dB@+6VGain flatness:  $\leq \pm$  1.5 dB ( positive slope ) P-1dB: 21 dB m @+5V , 21.5 dB m @+6VPsat: 22 dB m @+5V , 23 dB m @+6VPower supply: +5V/47mA , +6V/49mA500hm input/output 100% on-chip testing Chip size : 1.85 x 1.0 x 0.1mm

### **Product Introduction**

GPA-1314A is a wide voltage amplifier chip based on GaAs process , with a frequency range of 13.5~14.5GHz, a small signal gain of 29~30dB, and a P-1 output power of 21~21.5 Bm. The chip is powered by a +5V~ +6V power supply. The chip through-hole metallization process ensures good grounding, and the back side is metallized, which is suitable for eutectic sintering or conductive adhesive bonding process.

Use restriction parameter <sup>1</sup>		
Maximum drain voltage	+8 V	
Maximum input power	+2 0 dBm	
Operating temperature	-55 ~ + 85 °C	
Storage temperature	-65 ~ +150°C	

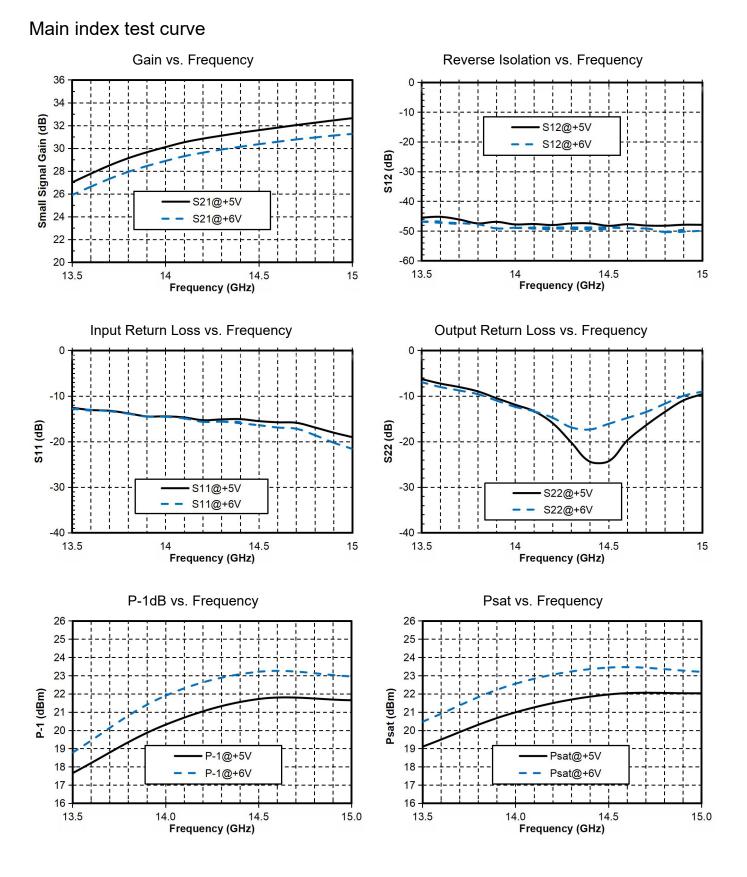
[1] Exceeding any of these maximum limits may cause permanent damage.

Electrical performance parameters ( TA $_{=}$ +25°C , Vd = +5V, +6V )					
index	Minimum	Typical Value	Maximum	unit	
Frequency Range	13.5~14.5			GHz	
Small Signal Gain	29~30@+5V~+6V			dB	
Gain Flatness		± 1.5		dB	
P -1 dB	21~21.5@+5V~+6V			dBm	
Psat	22~23@+5V~+6V			dBm	
Input return loss	14	15		dB	
Output return loss	9	16		dB	
Quiescent Current	47~49@+5V~+6V			mA	
*By tuning the Vg terminal voltage from -2V to 0V, it is recommended that the Vg terminal voltage be expected					

to be -0.9 V.

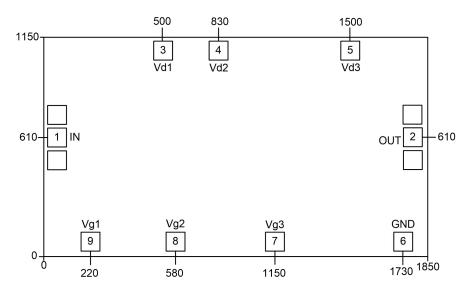


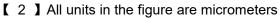
## GaAs MMIC Wide Voltage Amplifier Chip, 13.5-14.5GHz



# GaAs MMIC Wide Voltage Power Amplifier Chip, 13.5-14.5GHz

### Appearance structure <sup>2</sup>



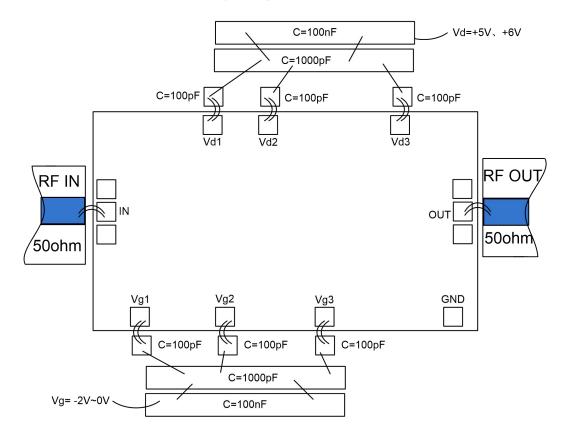


Bonding point definition				
Bonding point number	Function Symbol	Functional Description		
1	RF IN	RF signal input terminal, no DC blocking capacitor required		
2	RF OUT	RF signal output terminal, no DC blocking capacitor required		
3, 4, 5	Vd1 , Vd2, Vd3	Amplifier drain bias, requires external 100 pF, 1000pF, 100nF bypass capacitor		
6	GND	Dangling		
7, 8, 9	Vg1, Vg2, Vg3	Amplifier gate bias, external 100 pF, 1000 pF, 100 nF bypass capacitor required		
Chip bottom	GND	The bottom of the chip needs to be in good contact with the RF and DC grounds		



### GaAs MMIC Wide Voltage Power Amplifier Chip, 13.5-14.5GHz

Recommended assembly diagram



#### Notice

- The chip must be stored in an anti-static container and kept in a nitrogen environment.
- Do not attempt to clean the bare die surface using wet chemical methods.
- Please strictly follow the ESD protection requirements to avoid static damage to the bare chip.
- General operation: Please use precision pointed tweezers to pick up bare chips. Avoid touching the chip surface with tools or fingers during operation.
- Rack mounting operation suggestions: Bare chip mounting can be done by AuSn solder eutectic sintering or conductive adhesive bonding. The mounting surface must be clean and flat.
- Sintering process: It is recommended to use AuSn solder sheets with a gold-tin ratio of 80/20. The working surface temperature reaches 255 °C and the tool (vacuum chuck) temperature reaches 265 °C. When the high-temperature mixed gas (nitrogen-hydrogen ratio of 90/10) is blown to the chip, the temperature at the top of the tool should be raised to 290 °C. Do not let the chip exceed 320 °C for more than 20 seconds. The friction time should not exceed 3 seconds.
- Bonding process: The amount of conductive glue dispensed should be as small as possible. After the chip is placed in the installation position, the conductive glue can be vaguely seen around it. For curing



conditions, please follow the information provided by the conductive glue manufacturer.

 Bonding operation suggestions: Use Φ0.025mm (1mil) gold wire for both ball and wedge bonding. Thermosonic bonding temperature is 150 °C. The pressure of the wedge bonding knife is 40~50gf for ball bonding and 18~22gf for wedge bonding. Use the smallest possible ultrasonic energy. The bonding starts at the pressure point on the chip and ends at the package (or substrate).